APPLICATION DATA SHEET

APPLICATION INFORMATION

Application Type:: REGULAR Subject Matter:: UTILITY CD-ROM or CD-R?:: NONE

Title:: WAFER PROCESSING APPARATUS

HAVING DUST PROOF FUNCTION

Attorney Docket Number:: 245161US3 CIP

Total Drawing Sheets:: 7

INVENTOR INFORMATION

Applicant Authority Type:: INVENTOR

Primary Citizenship Country:: Japan

Status:: FULL CAPACITY

Given Name:: Tsutomu
Family Name:: OKABE
City of Residence:: Tokyo
Country of Residence:: JAPAN

Street of Mailing Address:: c/o TDK Corporation, 1-13-1, Nihonbashi,

Chuo-ku

City of Mailing Address:: Tokyo
Country of Mailing Address:: Japan
Postal or Zip Code of Mailing Address:: 103-8272

Applicant Authority Type:: INVENTOR

Primary Citizenship Country:: Japan

Status:: FULL CAPACITY

Given Name:: Hiroshi
Family Name:: IGARASHI
City of Residence:: Tokyo
Country of Residence:: JAPAN

Street of Mailing Address:: c/o TDK Corporation, 1-13-1, Nihonbashi,

Chuo-ku

City of Mailing Address:: Tokyo
Country of Mailing Address:: Japan
Postal or Zip Code of Mailing Address:: 103-8272

CORRESPONDENCE INFORMATION

Correspondence Customer Number:: 22850

REPRESENTATIVE INFORMATION

Representative Customer Number::

22850

DOMESTIC PRIORITY INFORMATION

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	Continuation-in-Part	10/330,092	12/30/02
	of		

ASSIGNMENT INFORMATION

Assignee Name::

TDK CORPORATION

Street of Mailing Address::

1-13-1, Nihonbashi, Chuo-ku,

City of Mailing Address::

Tokyo

Country of Mailing Address::

Japan